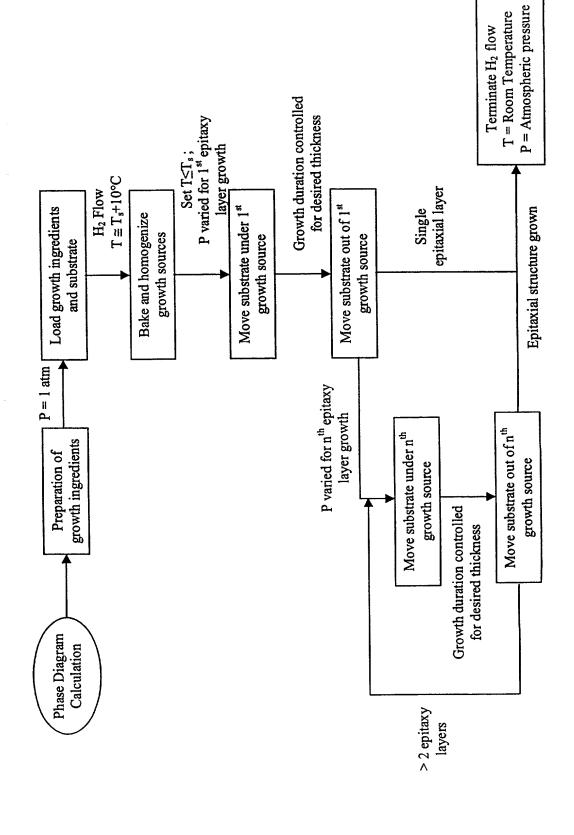
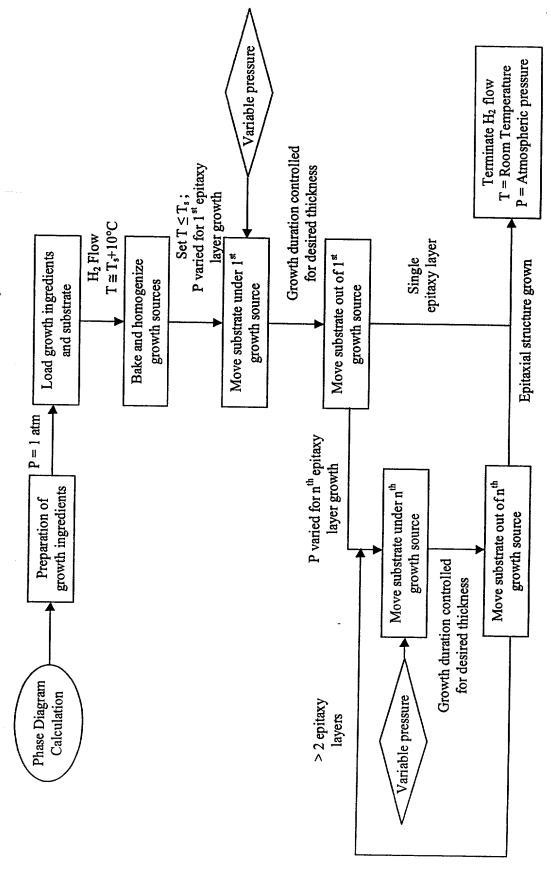
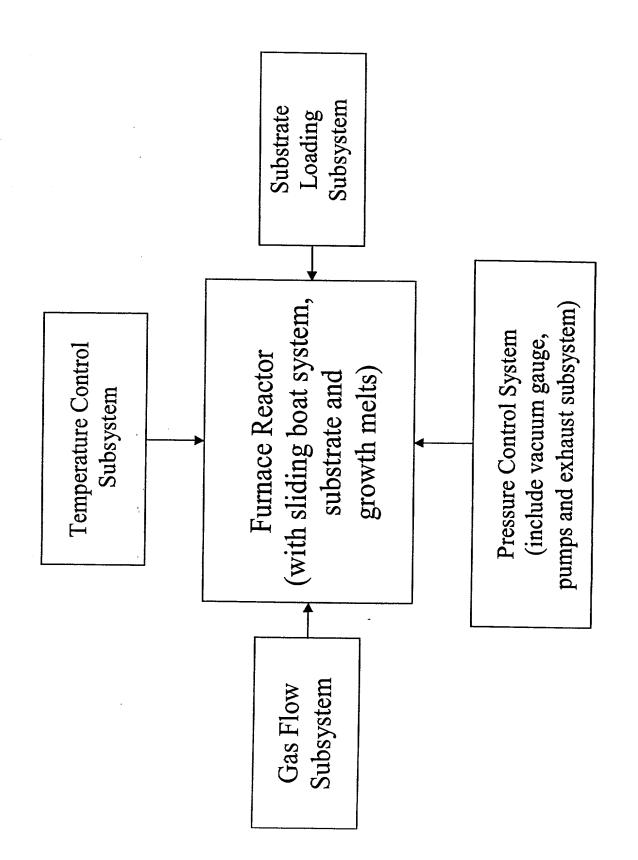
Growth of multiple non-compositional-graded layers

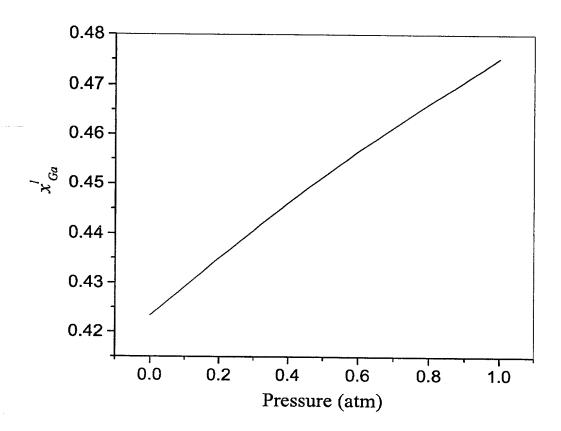


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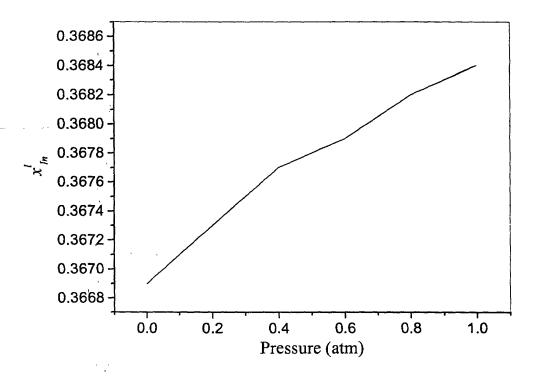




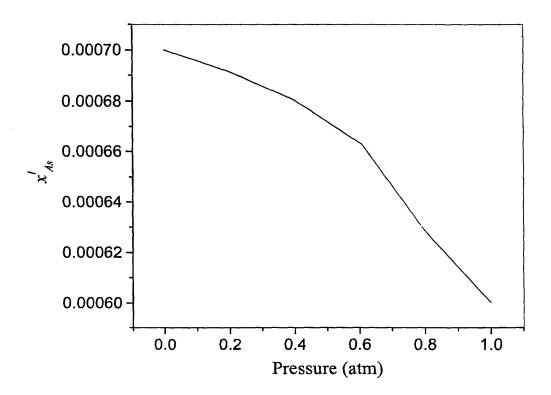




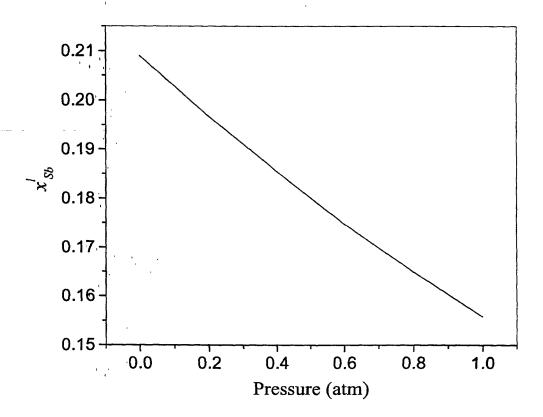
Atomic fraction x_{Ga}^l in melt for $In_{0.1}Ga_{0.9}As_{0.087}Sb_{0.913}$ growth on GaSb (100) substrate at 550 °C as a function of pressure.



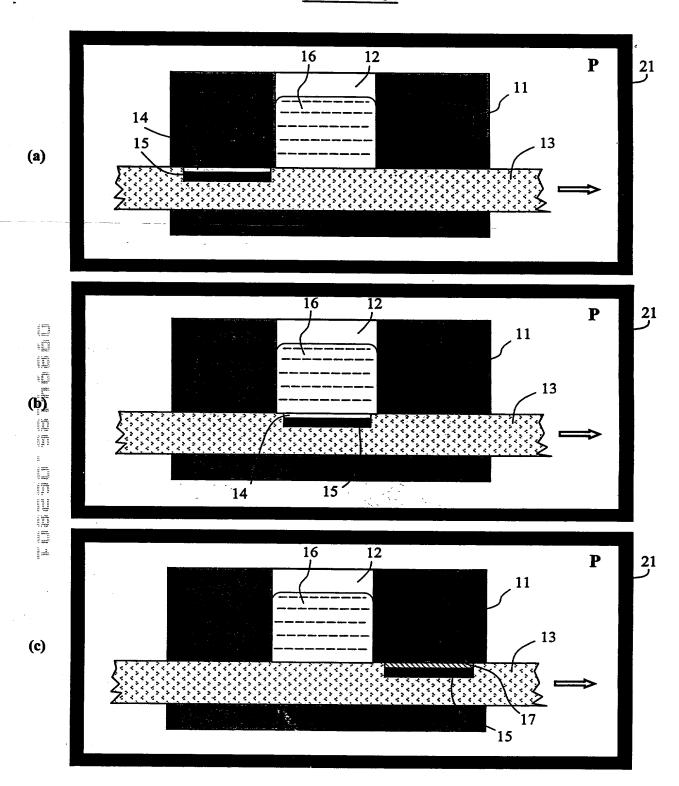
Atomic fraction x_{In}^{l} in melt for $In_{0.1}Ga_{0.9}As_{0.087}Sb_{0.913}$ growth on GaSb (100) substrate at 550 °C as a function of pressure.



Atomic fraction x_{As}^{l} in melt for In_{0.1}Ga_{0.9}As_{0.087}Sb_{0.913} growth on GaSb (100) substrate at 550 °C as a function of pressure.



Atomic fraction x_{Sb}^{I} in melt for $In_{0.1}Ga_{0.9}As_{0.087}Sb_{0.913}$ growth on GaSb (100) substrate at 550 °C as a function of pressure.



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